MOOV

1) SYSTEM COMPOSITION

SU-3100	NAME	Q'TY	OTHER
1	MAIN BODY	1	
2	chemical box	1	
3	Power Box	1	
4	Load port	4	
5	Part box	2	
6	VCR Recorder	1	
7	EFEM Block	1	

2) GENERAL SPEC

WAFER	TYPE	THICKNESS	DIAMETER	MAIN POWER			
	NUCH	725±25/75μm	300±0.2μm	UPS(ECSS)			
MAIN PRESSURE ALARM	DI,AIR,VAC,EXH,N2			SENSITIVITY			
PROCESS FORMULA				WEIGHT			
NANO NOZZLE	YES						
chemical nozzle 1	LAL15						
chemical nozzle 2	LAL1400						
SHILED PLATE FUNCTION	YES						

